503629627 12/30/2015

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE: NEW ASSIGNMENT

NATURE OF CONVEYANCE: ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
SUSUMU TAUCHI	12/04/2015
TAKASHI UEMURA	12/04/2015
KOHEI SATO	12/03/2015

RECEIVING PARTY DATA

Name:	HITACHI HIGH-TECHNOLOGIES CORPORATION
Street Address:	24-14, NISHI-SHIMBASHI 1-CHOME
City:	MINATO-KU, TOKYO
State/Country:	JAPAN

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	29544070

CORRESPONDENCE DATA

Fax Number: (202)628-8844

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ATTORNEY DOCKET NUMBER:	108353.25923US	
NAME OF SUBMITTER:	RICHARD R. DIEFENDORF	
SIGNATURE:	/Richard R. Diefendorf, Reg. No. 32,390/	
DATE SIGNED:	12/30/2015	

Total Attachments: 1

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PATENT 503629627 REEL: 037382 FRAME: 0187

ASSIGNMENT (譲 渡 証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me by Hitachi High-Technologies Corporation, a corporation organized under the laws of Japan, located at 24-14, Niehl-Shimbashi 1-chome, Minato-ku, Tokyo, Japan receipt of which is hereby acknowledged I do hereby sell and assign to said. Hitachi High-Technologies Corporation, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

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invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on evan date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted.

to be held and enjoyed by said Hitachi High-Technologies Corporation,

its successors, assigns or other legal representatives, to the full and of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made:

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or relatue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to Issue said Letters Patent to said Hitachi High-Technologies Corporation,

Signed on the date(s) indicated aside our signatures:

INVENTOR(S) (発明者フルネームサイン)	Date Signed (署名日)
1) Sessimie Zauche	12/4/2015
2) Japashi Hemura	12/4/2015
3) Kohen Sato	12/3/2015
4)	
5)	Value de la constant
6)	
7)	
8)	
9)	l Harris
10)	,

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RECORDED: 12/30/2015